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Docket No.: R2180.0191/P191  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Masami Seto et al.

Application No.: 10/789,980

Confirmation No.: 9655

Filed: March 2, 2004

Art Unit: 2818

For: SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING THE  
SAME

Examiner: T. T. V. Ho

**STATUS INQUIRY**

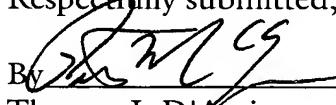
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: March 2, 2005

Respectfully submitted,

By   
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